

10/585522

AP20 Rec'd PCT/PTO 37 JUL 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Date: July 7, 2006

Nobuyuki Morimoto, Hideki Nishihata

Filed: July 7, 2006

Our Docket: SHX 367

For: PROCESS FOR PRODUCING SOI WAFER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97, and 1.98

Applicants are submitting this Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98 to disclose to the U.S. Patent and Trademark Office the patents, publications, applications, and/or other references listed on the enclosed, completed PTO-1449 form(s). The filing of this Information Disclosure Statement should not be construed as a representation that a search has been made or as an admission that the listed references are prior art for this application. Applicants respectfully request that the listed references be expressly considered during prosecution of the application, and that the references be made of record therein and appear among the "references cited" on any patents issuing therefrom.

CONTENT OF DISCLOSURE

This Information Disclosure Statement includes (1) one page of PTO-1449 forms, and (2) a legible copy of each foreign and non-patent reference, if any, listed on the form(s). However, because this application was filed on or after July 1, 2003, no copies of U.S. patents or published U.S. patent applications are included.

A concise explanation of the relevance of each listed reference not in the English language is attached to each reference.

TIMING OF DISCLOSURE / FEE INFORMATION

This Information Disclosure Statement is being filed with the application or with a Request for Continued Examination of the application under 37 C.F.R. §1.114. Therefore, in accordance with 37 C.F.R. § 1.97(b), no fee or statement under 37 C.F.R. § 1.97(e) is required.

Please contact the undersigned with any questions or comments regarding this Information Disclosure Statement.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 11-1540.

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Date of Deposit - July 7, 2006

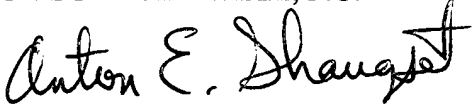
I hereby certify that the attached correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.



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Respectfully submitted,

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FORM PTO-1449		DOCKET NUMBER SHX 367		APPLICATION NUMBER 10/585522			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT(S) Nobuyuki Morimoto, Hideki Nishihata					
		FILING DATE July 7, 2006		GROUP ART UNIT			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FIL. DATE IF APPROP.	
	2003/0181001	9/25/2003	Aga et al.				
	2004/0161948	8/19/2004	Maleville et al.				
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES NO	
	11-02848	4/13/1999	Japan				X
	2000-124092	4/28/2000	Japan				X
	2003-224247	1/29/2002	Japan				X
	WO 03/009366	1/30/2003	WIPO				X
	WO 03/009386	1/30/2003	WIPO				X
OTHER DOCUMENTS							
	International Search Report for PCT/JP2004/019596 dated April 12, 2005.						
	Written Opinion for PCT/JP2004/019596 dated April 12, 2005.						
EXAMINER				DATE CONSIDERED			